

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	Air-curtain forming apparatus for wafer hermetic container in semiconductor producing device using mini-environment system
First Named Inventor/Applicant Name:	Toshiroo Kisakibaru
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)

1	Information Disclosure Statement (IDS) Filed	klw2471112_ids.pdf	140506 e12a939bcc2e07d0e9e51f1c3b2bb0cfde11335	no	8
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3	Foreign Reference	klw2471112_ref2.pdf	404161 9b906974e1cf147c1dc960015e2a52e35a6b337	no	7
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4	Foreign Reference	klw2471112_ref3.pdf	62109 ae0dab4b2f54348750a8d965e6fc7a40b6d0336c	no	2
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7	NPL Documents	klw2471112_ref6.pdf	86053 48512ff4ab965615ebb2d32b6d4c267d41417805	no	2
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8	NPL Documents	klw2471112_ref7.pdf	540405 d26bbe3d5ea14b87973917929c270a24e5ccdb25	no	6
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9	Information Disclosure Statement Letter	klw2471112_trans.pdf	79065 503a34edb53aaafc2c3dc901931af8f24f8121887	no	2

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10	Fee Worksheet (PTO-06)	fee-info.pdf	8245 d2d243030be3627859a93472f75922d2 47cf095d	no	2
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